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A redox reaction model for self-heating and aging prediction of Al/CuO multilayers

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Abstract

Sputter-deposited Al/CuO multilayers capable of highly energetic reactions have been the subject of intense studies for tunable initiation and actuation. Designing high performance Al/CuO-based initiator devices definitively requires reliable prediction of their ignition and reaction kinetics including self-heating or aging as a function of heating rate and environmental conditions. The paper proposes a heterogeneous reaction model integrating an ensemble of basic mechanisms (oxygen diffusion, structural transformations, polymorphic phase changes) that have been collected from recent experimental investigations. The reaction model assumes that the rate of reaction is limited by the transport of oxygen across the growing layer of Al₂O₃ separating Al and CuO. Importantly, we show that the model predicts reasonably all exotherms through a wide range of temperature (ambient - 1000 °C), all resulting from a pure diffusion process as experimentally observed for such Al/CuO multilayers. The model shows how the temperature ramp affects the structure of the multilayer and especially the growth of alumina-based interfacial regions. It highlights the importance of the interfacial chemistry evolution such as the native mixture of Al_xCu_yO_z transformation into a thin amorphous alumina, and the polymorphic phase transformation of this latter. The first one occurring at ~350 °C results in a loss of continuity of the interface leading to the accelerated redox

reaction whereas the second one occurring between 500 and 600 °C produces a denser barrier to oxygen diffusion leading to the stop of redox reaction. We finally use the model to simulate thermal annealing as usually performed in accelerated aging experiments. We theoretically observe and experimentally validate that a two weeks exposure of the multilayers at 200 °C starts degrading the multilayers thermal properties whereas when the temperature remains below 200 °C, the material keeps its entire integrity.

Keywords: energetic materials, Al/CuO multilayer, redox reactions; heterogeneous combustion

1. Introduction

Nanoscale sputter-deposited Al/CuO thermite multilayers have attracted considerable attention in recent years due to their reactive properties, e.g. high volumetric energy density, significantly higher than most conventional secondary explosives, long shelf lives and compatibility with silicon integrated circuit processing. After being ignited locally by an external source of energy (electrostatic discharge, mechanical impact or local heating), they are capable to promptly release high amount of heat with emission of light, thus opening opportunities for on-chip ignition and micro actuation [1-4]. Two decades of research in Al/CuO thermite multilayers have led to major progress in regulating either the fraction of material that reacts, or the time duration of the combustion, making it possible to envisage tunable initiation with further tailored energy and power outputs. However, despite huge experimental effort, the kinetics of both the initial exothermic reactions, leading to ignition, and low-temperature reactions, resulting in the material aging, remain elusive whereas it may greatly affect the sensitivity, overall exothermicity and ignition characteristics of the energetic multilayers. Although powderbased nanothermites are stable over long periods of time thanks to their protective alumina layer, sputter-deposited Al/CuO multilayers are separated by a much less

chemically controlled interfacial layer [5]. Therefore, it is reasonable to expect that both the ignition and aging kinetics are qualitatively and quantitatively different from those of the Al/CuO mixed powders with identical stoichiometry, dimensional features, and composition. Along this line, a very recent and thorough experimental study [6] showed that: (i) the interfacial thickness in sputtered Al/CuO multilayers is much larger than expected from usual surface native Al oxides, (ii) the release of gaseous O from the CuO well below reaction onset (i.e. at ~200 °C) initiates the Al oxidation process at the vicinity of native interfaces. (iii) the multiple subsequent redox reaction steps are the result of oxygen transport across the growing layer of Al₂O₃ separating Al and CuO. These findings, together with close examination of previous published results [7], allow us to propose a redox reaction model of Al/CuO sputter-deposited thin films integrating the structural and phase transformations, polymorphic phase changes occurring in Al₂O₃, in addition to thermally activated oxygen diffusion mechanisms coupled with heat equation. The final goal is to provide a new theoretical tool to simulate the calorimetric response of Al/CuO sputter-deposited multilayers under slow heating rates and predict how temperature ramp affects the structure of the multilayer and especially the growth of interface (Al₂O₃) making it possible, for the first time, to predict thermal aging. Herein, we detail the model implementation, parametrization and validation based on a large set of experiments using Differential Scanning Calorimetry (DSC) performed isothermally in a broad range of temperatures (ambient to 1000 °C). Its sensitivity to various material characteristics and heating conditions is explored. Then, the model is applied to simulate a two weeks accelerated thermal aging of Al/CuO multilayers at 100 and 200 °C demonstrating its capability in predicting aging-induced materials performance modifications.

2. Materials and methods

2.1 Materials

Al/CuO multilayers are sputter deposited by DC (Direct Current) magnetron sputtering technique on a 4 inches Si (100) wafer. Cu and Al targets (8 and 3 inches sides and ½ inches thick) are used for the deposition of CuO and Al thin films. The base pressure of the chamber is less than 5×10^{-7} mbar. O₂ and Ar gases flow rates of 16 and 32 SCCM (Standard Cubic Centimeters per Minute) respectively, are used for CuO deposition in reactive plasma at 600 W with a partial pressure of 8 mTorr, to obtain cupric oxide (CuO). The partial pressure during Al deposition is maintained at 4 mTorr in Ar plasma at 800 W. The Al and Cu target are localized in the same chamber. The sample stage moves at a speed of 244 cm/min and 320 cm/min respectively for the deposition of CuO and Al. The sample is cooled during 600 s at the end of the deposition process.

Different sets of samples are prepared. All have 10 bilayers but the bilayer thickness (w) and Al to CuO ratio (ς :1), ranges from 300 to 600 nm and 1:1 to 2:1, respectively. 1:1 Al/CuO bilayer is a stoichiometric stack, where the thickness ratio provides sufficient moles of O in CuO to fully oxidize all the initial Al layer into Al₂O₃. Note that in a 1:1 Al/CuO bilayer, the aluminum thickness is half the CuO thickness whereas in ς :1 Al/CuO, the Al thickness is $\frac{\varsigma}{2}$ of the CuO thickness, corresponding to a non-stoichiometric situation ($\varsigma \neq 1$). For model parametrization, 10 Al/CuO bilayers in fuel rich condition (2:1) are prepared, each layer (Al and CuO) being 200 nm in thickness. One advantage of this composition is that many experimentations on the reaction mechanisms are available in the literature [6,8].

2.2 Thermal analysis

The heat release during redox reaction of Al/CuO multilayers is studied isothermally by DSC, using a NETZSCH DSC 404 F3 pegasus device. The device is equipped with a DSC-C_p sensor type S and a Platinum furnace in a temperature range from room temperature to 1000 °C. Thermal analyses are performed under a constant heating rate in an Ar atmosphere. After the first heating cycle, the sample is cooled to room temperature, followed by a second heating cycle to correct the baseline. However, despite this second heating cycle, as the bulk heat capacity of the sample slightly drifts between the first and the second heating run, it is necessary to treat the experimental curves to obtain a suitable baseline. Note that this is a general difficulty encountered with DSC curves analysis due to the extended range of temperatures during the experiments combined with the complexity of Al/CuO redox chemistry [6]. As the baseline is not linear, as observed by Umbrajkar *et al.* [9], we choose to build baselines following the isoconversional principle, assuming that the extent of reaction is conserved while following main exothermic events, at any heating rate.

2.3 Theoretical approach

We first use a model-free approach to evaluate the reaction kinetic parameters from the DSC curves. The best-known approach, if several measurements with different heating rates and/or different temperatures ranges are performed, is the method developed by Kissinger [10]. An effective reaction progress rate equation $\frac{d\alpha}{dt} = k_o \exp\left(-\frac{E_a}{RT}\right) \cdot f(\alpha)$ is presumed where α is the extent of reaction, and E_a and k_o are the activation energy and pre-factor associated with the transformation reaction, respectively. Assuming that DSC curve reaches a maximum at the peak transformation rate, the dependence of the peak temperature (T_p) and the heating rate $(\beta = \frac{dT}{dt})$ can be found by setting to zero the

derivatives of the rate equation with respect to time. In the case of first-order reaction, *i.e.* $f(\alpha) = (1 - \alpha)$, the resulting expression gives the so-called Kissinger equation:

$$ln\left(\frac{\beta}{T_P^2}\right) = ln\left(\frac{k_o R}{E_a}\right) - \frac{E_a}{RT_P} \tag{1}$$

with R, the ideal gas constant. Eq. 1 predicts that the plot $\ln \left(\frac{\beta}{T_P^2} \right)$ against $\frac{1}{RT_P}$ is a straight line with a $-E_a$ slope. However, despite the intensive application of Kissinger's method in interpreting DSC data [9,11–13], significant inaccuracies in the determination of E_a may arise from the inherent methodological approximation. First, the physical meaning of the apparent kinetic parameters is not always clear: the concept of reaction progress should be limited to independent reactions occurring successively after each other, within specific temperature ranges, which is not the case in our system where elementary physical mechanisms interact with each other and occur concurrently at all temperatures, according to their specific kinetics. Also, thermal analysis data is fitted to an assumed $f(\alpha)$ function that can be chosen from a wide list of different functions that depend on the originating mechanisms [14], and using a "trial-and-error" procedure. Often for practical reasons, only first-order functions are considered which cannot interpret complex redox reaction and multiple phase transformation mechanisms, which may interfere within a single DSC peak. That is why we also developed an alternative method for the derivation of activation energies which is based on the setting up of a Fick diffusion equation implemented in the Deal & Grove formulation [15], coupled with a thermal equation. Recently, this coupled approach enabled us to propose a combustion model that was inaugurated to perform flame velocity prediction in Al/CuO multilayers, assuming a simple and reduced set of mechanisms [7]. We propose here to adapt it simulate heterogeneous redox reaction. Overall, considering 3 layers i, j, k (see **Figure 1**), the model is based on four main equations:

• Material structural modification such as CuO densification and polymorphic phase change (amorphous to γ - Al_2O_3 transition) where an old structure is transformed into a new one at a given velocity. Until the transformation is complete, the variation of thicknesses is expressed as:

$$dw_j/dt = v_{0j}e^{-E_j/RT} (2)$$

where w_j is the thickness of the considered j phase (initially set to zero), v_{0j} and E_j are respectively the velocity pre-exponent and activation energy relative to the phase transformation.

Material chemical modification such as CuO reduction leading to oxygen release,
 where the associated reaction progress is given as:

$$\frac{d\alpha_i}{dt} = A_i e^{-E_i/RT} f_i(\alpha_i)$$
 (3)

Where α_i is the extent of reaction (initially set to 0, and equal to 1 when the reaction is complete), A_i and E_i are the pre-exponent and activation energy relative to the chemical modification of the material i. The progress function $f_i(\alpha_i)$ relates to the reaction type (diffusion, reaction, crystallization ...) [14].

 Mass transport equation in the flux (Ø) approximation. Note that we only consider oxygen diffusion in our model:

$$\emptyset = \frac{D_j(C_{i/j} - C_{j/k})}{w_j} \tag{4}$$

where D_j is the oxygen diffusivity in the material j, the variables $C_{i'j}$, $C_{j'k}$... are the oxygen concentrations at interfaces between materials i and j, j and k. w_i , w_k , ... correspond to the thicknesses of materials i, j, k (see **Figure 1**). The oxygen diffusivity is expressed as:

$$D_j = D_{oj} e^{-E_j/RT} (5)$$

For each layer, the pre-exponent D_{oj} and activation energy E_j are either taken from the literature relative to Al/CuO nanopowder or calibrated on thermal analysis performed on our sputter-deposited 2:1 Al/CuO stacks. Parametrization issues are detailed in Results section 3.2.

• Thermal equation:
$$P = \frac{dH(t)}{dt} - n S \phi \times Q$$
 (6)

P is the differential external power (in W) as measured in DSC experiments. The total enthalpy H (in J/m³) is expressed as: $H(t) = H_a + \sum_{T_i > T_a} M_i \; h_i \; \theta(T(t) - T_i)$ (7) With, H_a , the total enthalpy of the bilayer at ambient temperature (T_a) and T_a and T_a

The term $\phi \times Q$ represents the heat released by the redox reaction at the Al/oxidizer interface $(i+k \rightarrow j \text{ in Figure 1})$. Note that Q is the heat of formation of the aluminium oxide in J/mol, is the oxygen flux across one bilayer in mol/m³/s, n represents the number of bilayers in the film and S its surface.

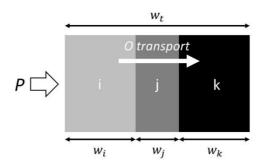


Figure 1. Schematic of one bilayer system submitted to a power density *P*. End to end repetition of this elementary bilayer unit constitutes a multilayer system.

3. Results & Discussion

3.1 Thermal analysis

Figure 2 shows the DSC curves of 2:1 Al/CuO multilayers (w=400 nm) stacks collected at 5, 10, 20 and 40 °C/min. In each curve, we observe three main and reproducible exothermic events. A first broad exothermal event is observed between 350 and 540 °C (■) followed by a strong exothermal peak at 540 - 670 °C (●). A last exotherm at high temperature is detected between 670 and 900 °C (▲). Between 200 – 350 °C, the copper oxide releases oxygen atoms that diffuse across the interfacial layers to oxidize the neighboring aluminum and form amorphous alumina (am Al_2O_3). Because am Al_2O_3 density is substantially higher than that of naturally grown interface (mixture of Al, O and Cu), the structure of the interface is mechanically degraded at ~350 °C $(damaged Al_2O_3)$ leading to the accelerated redox reaction [5]. The resulting increase in am Al_2O_3 layer thickness provides a barrier to the oxygen diffusion that slows down Al oxidation, thus reducing the heat release corresponding to the drop of the first exotherm in the DSC trace (■). The second exothermal peak (•) corresponds to the main reaction stopped by a polymorphic phase change $(am Al_2O_3 \rightarrow \gamma - Al_2O_3)$. Then Al oxidation continues through the γ - Al_2O_3 before and after the aluminum melting. At 500 °C, the XRD spectrum (Supplementary file Figure S1) presents a clear increase and welldefined Cu₂O peaks with a small detection of a broad Cu (200) peak around 50.8°. But, Al_2O_3 phase is not yet detected, as it is still in its amorphous phase. Formation of γ - Al_2O_3 clearly occurs between 500 and 700 °C as it is detected at 700 °C. At 700 °C (end of strong exothermal peak), traces of CuAl₂ alloys are also detected by XRD as expected as the sample is Al rich.

Based on the Kissinger method described in the *Theoretical approach* subsection, the plots of $ln(\beta/T_p^2)$ vs. $1000/T_p$ at each T_p are shown in the **Supplementary file Figure S2**. The slopes of the straight lines corresponding to each group of data points correspond to activation energies (155, 206 and 290 kJ/mol) related to exothermic peak 1 (\blacksquare), peak 2 (\bullet) and peak 3 (\blacktriangle), respectively.

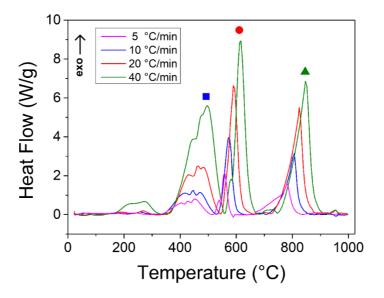


Figure 2. Experimental DSC curves of ten 2:1 Al/CuO bilayers (*w*=400 nm) collected at different heating rates. Symbols are used to identify the exothermic peaks. Curves represent one experimental set repeated twice, to ensure that trends are well-captured.

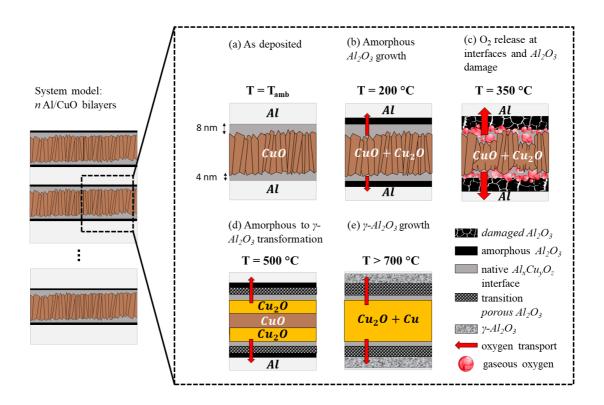


Figure 3. Schematics of the mechanisms proposed for describing the Al+CuO redox reaction in sputter-deposited stacks under slow heating rate from ambient to 700 °C.

3.2 Model

The modelled system is a stack of $n \in 1$ Al/CuO bilayers. As evidenced on the Scanning Transmission Electron Microscopy (STEM) and Transmission Electron Microscopy (TEM) micrographs given in **Supplementary file Figure S3**, at ambient, both CuO/Al and Al/CuO interfaces are considered to have the same chemical nature (mixture of Al, Cu, O) but different in thickness. The interface formed upon the deposition of CuO onto Al is of 4 ± 0.3 nm in thickness whereas the interface created upon the deposition of Al onto CuO rough with an average thickness of 8 ± 3 nm. These barrier layers prevent the redox reaction from occurring at low temperatures (< 200 °C). Note that the redox reaction $2Al + 3CuO \rightarrow Al_2O_3 + 3Cu$ is assumed with a heat of reaction (Q) of 3.9 kJ/g for stoichiometric conditions and 3.3 kJ/g for a reactant Al:CuO ratio of 2:1 as shown in [16].

Based on experimental observations described in previous section, a phenomenological model based on seven main mechanisms sketched in **Figure 3**, is implemented:

- (1) Oxygen diffusion through the native interfaces. Activation energy $E_{a\ Al_xCu_yO_z}$ and pre-exponent $D_{0\ Al_xCu_yO_z}$ are determined to fit the experimental first DSC peak (\blacksquare).
- (2) Oxygen diffusion through $am Al_2O_3$ characterized by activation energy and preexponent $(D_0 \ _{am \ Al_2O_3}, E_{a \ _{am \ Al_2O_3}})$.
- (3) Oxygen release resulting from the CuO reduction in several steps. According to reference [17], the reduction of CuO thin films can be described by the progress function $f_0(\alpha_0)$ given by an Avrami-Erofeev mechanism:

$$f_0(\alpha_0) = n \times (1 - \alpha_0)[-ln(1 - \alpha_0)]^{(n-1)/n}$$
 (8)

The value of the reaction progress α_0 is defined as being directly proportional to the global reaction progress α as follows: $\alpha_0 = c_0 \times \alpha$. c_0 is a coefficient adjusted to achieve the best match with the experimental DSC curves.

Thus, the oxygen release mechanism is expressed following equation 3:

$$\frac{d\alpha_O}{dt} = A_O \exp(-E_{\alpha_O}/RT) f_O(\alpha_O)$$
 (9)

The activation energy (E_{a_O}) and pre-exponent (A_O) are fitted to DSC curves using the Kissinger method to obtain a first estimate, and then adjusted considering the progress function $f_O(\alpha_O)$.

(4) Oxygen diffusion through damaged Al_2O_3 . We assume that the kinetic of am Al_2O_3 to damaged Al_2O_3 transformation is directly linked to the oxygen release as follows:

$$v_{am \to damaged} = v_0 \frac{d\alpha_0}{dt} \tag{10}$$

Where $v_{am\rightarrow damaged}$ is the growth velocity of damaged Al₂O₃ layer, and v_0 is a coefficient.

(5) Transformation of the $am\ Al_2O_3$ into a "porous γ - Al_2O_3 " according to the process described by Simpson $et\ al.$ [18,19]. We assume that the kinetic of amorphous to porous γ - Al_2O_3 follows an Arrhenius law:

$$v_{am\to\gamma} = v_{0\ am\to\gamma} \ e^{-\frac{E_{a_{am\to\gamma}}}{RT}} \tag{11}$$

where $v_{am\to\gamma}$ is the growth velocity of porous $\gamma - Al_2O_3$ layer, $v_{0\ am\to\gamma}$ is the preexponent, and $E_{a\ am\to\gamma}$ is the activation energy. Oxygen diffusion through porous alumina is considered very fast according to [20,21] but the oxygen diffusion resistance depends linearly on the oxide thickness as:

$$D_{porous} = A_{porous} \left(1 - \frac{w_{porous}}{w_{porous}^{max}} \right) D_{\gamma - Al_2 O_3}$$
 (12)

 D_{porous} and $D_{\gamma-Al_2O_3}$ are the oxygen diffusion coefficients into the porous and bulk γ - Al_2O_3 , respectively. w_{porous} is the porous layer thickness and, w_{porous}^{max} is the thickness beyond which $D_{porous} = D_{\gamma-Al_2O_3}$. A_{porous} is a fitting coefficient corresponding to the initial value of oxygen diffusivity in the "porous γ - Al_2O_3 ". Once the porous layer diffusion resistance becomes higher than that of γ - Al_2O_3 , the growth of amorphous Al_2O_3 is stopped and that of γ - Al_2O_3 is activated.

- (6) Oxygen diffusion through γ - Al_2O_3 characterized by activation energy and preexponent ($D_{0\gamma-Al_2O_3}$, $E_{a\gamma-Al_2O_3}$) [21,22].
- (7) Densification of CuO. The sputter-deposited CuO density, $\rho_{0 CuO}$, is most of the time less dense than bulk CuO. Therefore, the CuO layer can shrink upon heating as observed experimentally in [6]. The densification is implemented as:

$$v_{CuO\ shrinkage} = \left(\frac{w_{CuO}}{\rho_{CuO}}\right) \frac{d\rho_{CuO}}{dt} \tag{13}$$

with
$$\frac{d\rho_{CuO}}{dt} = (\rho_{th\ CuO} - \rho_{0\ CuO}) \frac{d\alpha_{CuO\ shrinkage}}{dt}$$
 (14)

 w_{CuO} and ρ_{CuO} are the CuO layer thickness and time-dependent density, respectively.

The progress rate of shrinkage $\frac{d\alpha_{CuO\ shrinkage}}{dt}$ is fitted to DSC curves using the Kissinger method assuming the determination of the activation energy ($E_{a\ CuO\ shrinkage}$) and preexponent ($k_{0\ CuO\ shrinkage}$) associated with this transformation reaction.

In addition, Al melting is considered in equation 7 ($\Delta H_{Al}^{melt} = 10.79$ kJ/mol) whereas all phase transitions involving intermetallic compounds are neglected. Finally, to account for a spontaneous aluminum oxidation in the presence of oxygen, its reaction rate is fixed at high velocity, 3000 m/s, with no activation barrier [7].

Table 1 summarizes the activation energies and pre-exponents for each identified mechanism and their sources (DSC-based fitting, Kissinger or literature). In summary, the kinetic parameters describing mechanism 1, 3, 4, 5, and 7 are fitted from the DSC measurements (first (\blacksquare) and second (\bullet) peaks of **Figure 2**). Although reported to be fast, the diffusivity of oxygen in porous γ - Al_2O_3 layers (mechanism 5) is not documented in the literature. $D_{porous\ \gamma Al_2O_3}$, and growth velocity of porous layer, $v_{am \to \gamma}$, were computed simultaneously in order to obtain the best match with the second DSC peak (\bullet).

Because of the presence of huge number of defects, the diffusivity of oxygen in *damaged* Al₂O₃ (mechanism 4) should be even faster. As a consequence, and to avoid introducing arbitrary parameters into the model, oxygen diffusivity through this *damaged* Al₂O₃ layer is considered as infinite. In mathematical terms, the infinite diffusivity implies a uniform

concentration of oxygen throughout the layer. Finally, the kinetic parameters describing, oxidative growth of am and γ - Al_2O_3 are taken from the literature [21,22].

Table 1. Model parameters for each mechanism.

| Mechanism | Parameters | Fitted to |
|---|--|-------------------------------|
| Oxygen diffusion through natural Al _x Cu _y O _z . | $D_{0 Al_x Cu_y O_z} = 1 \times 10^{-7} \text{ m}^2/\text{s}$ $E_{a Al_x Cu_y O_z} = 100 \text{ kJ/mol}$ | DSC (peak ■) Figure 2 |
| Oxygen diffusion through $am Al_2O_3$. | $D_{0 am Al_2O_3} = 1.67 \times 10^{-11} \text{ m}^2\text{/s}$ $E_{a am Al_2O_3} = 120 \text{ kJ/mol}$ | [22] |
| Oxygen release from CuO reduction. | $A_O = 1.3 \times 10^4 \text{ s}^{-1}$ $E_{a_O} = 90 \text{ kJ/mol}$ $n = 1.2$ $c_O = 0.18$ | DSC (Figure 2 peak ■) |
| Oxygen diffusion through damaged Al_2O_3 . | $D_{damaged \gamma Al_2O_3} = \infty$ $v_0 = 3 \times 10^{-8}$ | DSC (Figure 2 peak ■) |
| Amorphous $\rightarrow \gamma$ polymorphic phase transformation in Al ₂ O ₃ . | $v_{0 \ am \to \gamma} = 1.5 \times 10^7 \text{ m/s}$ $E_{a \ am \to \gamma} = 206 \text{ kJ/mol}$ | Kissinger methods Figure S2 |
| Oxygen diffusion through porous γ - Al_2O_3 . | $w_{porous}^{max} = 21 \text{ nm}$ $A_{porous} = 700$ | DSC (Figure 2 peak ●) |
| Oxygen diffusion through $\gamma - Al_2O_3$. | $D_{0 \gamma - Al_2 O_3} = 5 \times 10^{-5} \text{ m}^2/\text{s}$ $E_{a \gamma - Al_2 O_3} = 290 \text{ kJ/mol}$ | [21,22] |
| CuO densification. | $k_{0_{CuO\ shrinkage}} = 3 \times 10^{-10} \text{ s}^{-1}$ $E_{a\ CuO\ shrinkage} = 177 \text{ kJ/mol}$ | DSC (Figure 2 peak ■) |

The reaction model with the adjusted kinetic parameters is finally implemented into numerical codes in C to predict the evolution of the different layer thicknesses (Al, CuO, Cu₂O, Al₂O₃...), upon annealing, and to simulate virtual DSC of sputter-deposited Al/CuO multilayers (see Supplementary file Figure S5). Comparison between calculated and experimental results are presented and discussed in the next subsection before presenting the effect of thermal annealing on thermal response.

3.3 Model vs experiments comparison

Alumina growth simulation upon heating. **Figure 4** plots the thickness evolution of the growing Al₂O₃ barrier layer at both interfaces when increasing the temperature of a trilayer Al/CuO/Al with Al and CuO thicknesses equal to 100 and 300 nm, respectively. The ramping is 10 °C.min⁻¹ and a 10 minutes annealing step is performed at selected temperatures, 25, 200, 300, 350, 400, 500 °C, after which high magnification TEM images are taken allowing determination of oxide layer thicknesses (summarized in Supplementary file **Figure S3**).

Dashed lines correspond to simulations of the overall annealing procedure and small triangles and circles give the experimental measurements. Overall, simulations match well with experimental data: ~ 25% discrepancy is obtained due to noticeable deviation at high temperatures (500 °C), which is reasonable since mechanisms such as delamination or potential Al/Cu allowing evidenced experimentally [6] are not taken into account in the model.

At low temperature (below 200 °C), the simulated amorphous alumina growth rates look similar despite the pre-existence of differences in natural interface thicknesses. However, the much higher roughness of the CuO/Al interface leads to poor precision of the measured thickness, as seen from the error bars, which hinders quantitative comparison. The underestimation of simulated thicknesses at 200 °C may arise from the cooling down of the experimental which is not spontaneous and may promote further oxide growth. In the intermediate regime, ~300-350 °C, the alumina growth rate suddenly increases at both interfaces. We assume that the growing amorphous alumina becomes permeable to oxygen migration due a stress-induced deterioration of the layer. This causes a brutal enhancement of the redox reaction and oxidation rate (× 5).

Interestingly, in this transition, we observe a crossing over of experimental and simulated curves, leading to overestimation of the grown thicknesses at 500 °C, for both interfaces. This effect can be related to the fact that parameters of influence here emanate from DSC measurements in which we assume complete overall exothermic Al + O reactions, which is never the case experimentally.

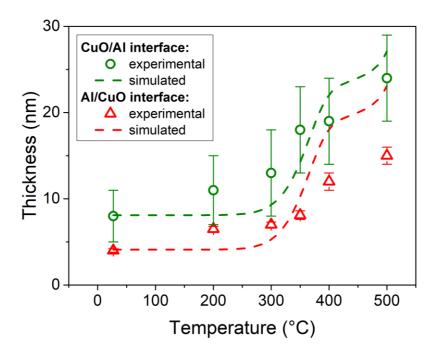


Figure 4. Simulated and measured interfacial oxide layers thickness evolution upon heating. Heating rate is 10 °C.min⁻¹ and Al/CuO/Al stacks (total thickness of 500 nm) are annealed 10 min at each selected temperature (25, 200, 300, 350, 400, 500 °C). *Calorimetric response simulation*. **Figure 5** compares the thermo-analysis experiments (dashed line) with simulated one (solid line) obtained with a ramping of 10 °C.min⁻¹ for two samples of Al/CuO multilayers made of ten bilayers (w=300 nm and 600 nm) prepared in stoichiometric condition (ς =1). Note that the choice of ten 1:1 Al/CuO bilayers is made to avoid working on the same type of sample that were used to parameterize the model.

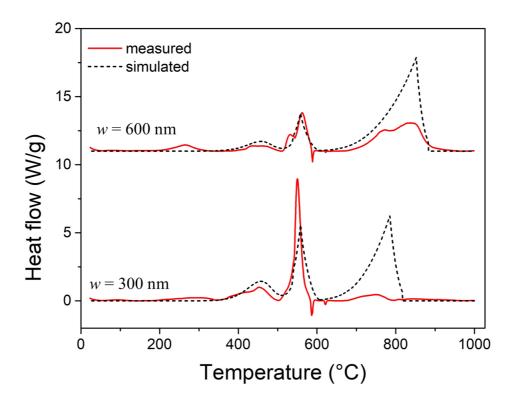


Figure 5. Simulated (dashed lines) and experimental (solid lines) DSC traces for ten 1:1 Al/CuO bilayers featuring two bilayer thicknesses: 600 and 300 nm.

The model simulates all exotherms obtained in experimental DSC: it predicts the three main reaction steps at 440, 578 °C and close to 800 °C with very good accuracy. Further, in the absence of any accurate data, the theoretical melting of Al has been set to 660 °C (endotherm) the bulk melting point, whereas it experimentally occurs at a lower temperature, due to the nanometric thickness of the layer. However, no exotherm is predicted below 300 °C whereas we can detect weak exotherms experimentally at around 250 °C (especially for thicker bilayer w=600 nm), which may be due to dehydration or recrystallization.

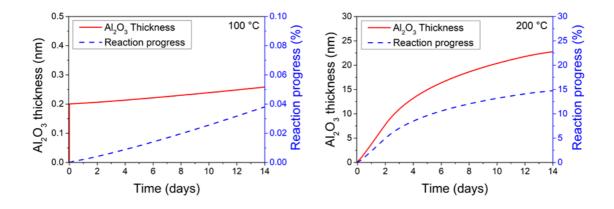
3.4 Aging prediction

The model is now used to predict how long-term thermal annealing affects multilayers thermal properties. For that purpose, we now consider 3 samples of ten 2:1 Al/CuO

bilayers, each layer being 200 nm thick (w=400 nm), as commonly used for ignition applications.[23,24] One of these samples is characterized by DSC after deposition [6], the two others are annealed two weeks at 100 °C and 200 °C respectively, before being characterized by DSC.

In parallel, we simulated the growing alumina thickness at the interface during the annealing steps (See **Figure 6**) at 100 and 200 °C.

At 100 °C, no noticeable modification of interface thicknesses is observed; the overall reaction progress remains below 0.04 % of the initial heat of reaction after two weeks, and it reaches 1.6 % after one year. At 200 °C, the reaction progress reaches 14.9 % of the initial heat of reaction after two weeks, and increases only to 16.8 % after one year. We predict a slight increase of the interface thickness corresponding to the growth of an ultrathin layer of amorphous alumina: the $am\ Al_2O_3$ growth is 0.25 nm and 2.6 nm after two weeks and one year annealing at 100 °C, respectively. At 200 °C the $am\ Al_2O_3$ growth is 22.6 nm and 19.4 nm after two weeks and one year, respectively. The discontinuous behaviour observed on top left graph in **Figure 6** corresponds to the quick formation of a diffusion barrier when the temperature is brutally switched from ambient to higher temperatures.



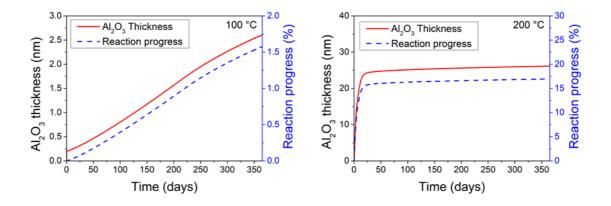


Figure 6. Simulated *am* Al_2O_3 growth and reaction progress (dashed line) for ten 2:1 Al/CuO bilayers (w=400 nm) annealed two weeks and one year at 100 and 200 °C.

DSC traces of aged samples are plotted in **Figure 7** with simulated ones. We observe consistent results with the evolution of oxide layer thickness plotted in **Figure 6**. Even though all mechanisms are considered to be active at all steps of the reaction, we already saw that DSC is typically characterized by a first exotherm (\blacksquare at 440 °C in **Figure 5**) corresponding the first step of copper oxide reduction releasing oxygen atoms that diffuse across the natural interfacial layer to oxidize the neighboring aluminum and form amorphous alumina ($am\ Al_2O_3$). The model indicates us that annealing the bilayer 10 days at 200 °C, is enough to grow a thin 20 nm $am\ Al_2O_3$ thus modifying the nature of the interfaces. As a result, the first exotherm usually seen on as deposited films disappears from the DSC scan after the annealing procedure (See **Figure 7**). The second exotherm is associated with the transformation of amorphous alumina into a γ - Al_2O_3 . We observe that the intensity of the second exotherm remains unchanged for samples annealed at 100 °C and 200 °C in comparison with the freshly produced samples.

These results are valuable because they not only provide information about the reaction progress, but also on which mechanisms are affected during the aging process. The vanishing of low temperatures exotherms may have a strong impact on combustion

behaviour, such as higher ignition time or lower flame velocity. After observing the endotherm of aluminum melting at 660 °C, a third exotherm peak is seen, which is related to the activation of the oxygen diffusion trough γ -alumina. A good qualitative agreement is observed between the experimental and calculated peaks over both annealing. The slight overestimation may be due to lacking high temperature phenomena in the model that affect DSC experimental measurements, such as delamination of Al/CuO interfaces.

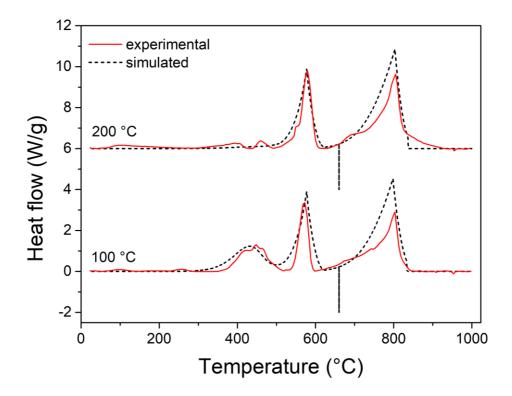


Figure 7. Simulated and experimental DSC traces of samples made of ten 2:1 Al/CuO bilayers (w=400 nm) annealed two weeks at 100 and 200 °C.

3.4. Influence of the ramping

In the following, we consider ten 2:1 Al/CuO bilayers, each layer being 200 nm thick (w=400 nm) and simulated their calorimetric responses at different ramping : 100, 1000 and 10^9 °C.min⁻¹ (See **Figure 8**).

Increasing the ramping temperature to 100 °C.min⁻¹, we only observe two main exotherms, where three were visible at 10 °C.min⁻¹. This is due to the merging process of the first two exotherms, which process is clearly visible from the associated DSC curve in **Figure 8**, with a shouldering of the first peak. Increasing heating rate to 10⁹ °C.min⁻¹ does not modify the thermal response. Except for the preceding merging process that is no more distinguishable for both 1000 and 10⁹ °C.min⁻¹ ramps. Interestingly, the overall exotherm temperature onset has shifted from 400 to roughly 1000 °C which could be correlated to the various initiation temperatures required by different ignition apparatus: hot wire, laser, resistor ... In this scope, this phenomenological model could easily be turned to simulate initiation and propagation of a realistic multilayer, as in [7]. This would allow, within a single physico-chemical core calculation, (i) to predict Al/CuO multilayers aging, (ii) to perform virtual DSC characterization and (iii) to determine associated performances.

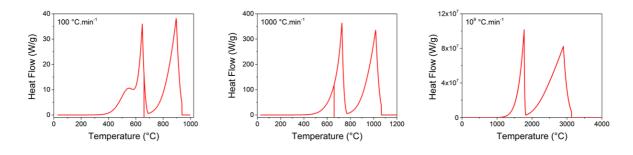


Figure 8. Simulated DSC curves for ten 2:1Al/CuO bilayer (w=400 nm) at three different heating rates, 100, 1000 and 10 9 °C.min⁻¹.

4. Conclusion

A heterogeneous redox reaction model was developed integrating an ensemble of basic mechanisms (oxygen diffusion, structural transformations, polymorphic phase changes) that have been collected from experimental investigations. The reaction model assumes that the rate of reaction is limited by transport of oxygen across the growing layer of

Al₂O₃ separating Al and CuO. For each mechanism, kinetic parameters are adjusted based on results taken from the literature or to fit with one set of experimental DSC obtained on 2:1 Al/CuO multilayers. The model was used to simulate the calorimetric response of Al/CuO multilayers, with different reactant ratios (different from validation set) and thicknesses, performed isothermally at well-controlled heating rates. The simulated results qualitatively match the experimental observations. We further demonstrated that this new theoretical tool can easily predict how temperature ramp affects the structure of the multilayer and especially the growth of interface (Al₂O₃) making it possible, for the first time, to evaluate individual to synergistic exothermic reaction steps which dominate the different stages of reaction progress. As a perspective, this model could further simulate ignition involving much higher heating rates than thermo-analytical technique and therefore constitute a precious tool to design energetic multilayered systems requiring reliable prediction of their ignition kinetics, energetics and, aging.

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